



Corres. and Mail

RESPONSE UNDER 37 C.F.R. § 1.116 EXPEDITED PROCEDURE REQUESTED EXAMINING GROUP 2125

PATENT Customer No. 22,852

Attorney Docket No. 07942.0007-00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	
Neal KUO) Group Art Unit: 2125
Application No.: 09/900,165) Examiner: Kidest Bahta
Filed: July 9, 2001))) Confirmation No. 5417
For: METHOD AND SYSTEM FOR) Commination No. 5417

DETERRING THE BEST INTEGRAL PROCESS PATH TO PROCESS SEMICONDUCTOR

PRODUCTS TO IMPROVE YIELD

Mail Stop AF

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

AMENDMENT AFTER FINAL

In reply to the Final Office Action mailed February 3, 2005, and pursuant to 37 C.F.R. § 1.116, Applicant proposes that this application be amended as follows:

Remarks follow the amendment sections of this paper.